



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Akio KOBAYASHI et al.

Application No.: 10/041,633

Filed: January 10, 2002

For: METHOD FOR PROCESSING CELLS

Group Art Unit: 2878

Docket No.: 111632

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INFORMATION DISCLOSURE STATEMENT

Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The references were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.

Respectfully submitted,

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JAO:TJP/al

Date: June 24, 2002

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Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 111632		APPLICATION NO. 10/041,633	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Akio KOBAYASHI et al.		SEP 18 2002	
				FILING DATE January 10, 2002		GROUP 2878	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
		5,916,788	06/29/1999	Kubota et al.			
		5,486,171	01/23/1996	Chou			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
		EP 0 483 847 A2	05/06/1992	Europe			
		EP 0 334 539 A2	09/27/1989	Europe			
		WO 93/20762	10/28/1993	WIPO			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
		HENRIKSEN, ASSMANN: "Laser-assisted patch clamping: a methodology" PFLUGERS ARCH-EUR J PHYSIOL, vol. 433, 1997, pages 832-841, XP002197942					
EXAMINER				DATE CONSIDERED			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: June 24, 2002